# SOS GROUP

### KLA Tencor INSPEX EAGLE Patterned Wafer Laser Inspection sn 0201002-E25

Information contained in this presentation is confidential

## **KLA Tencor INSPEX EAGLE**

#### **Patterned Wafer Laser Inspection**

Wafer Size: 150mm capable 4" up to 8" Equipment Details: Wafer inspection system Chuck, 6" Prealigner, 6" Cassette to cassette handling (2) Ports ZEISS Microscope Including manuals



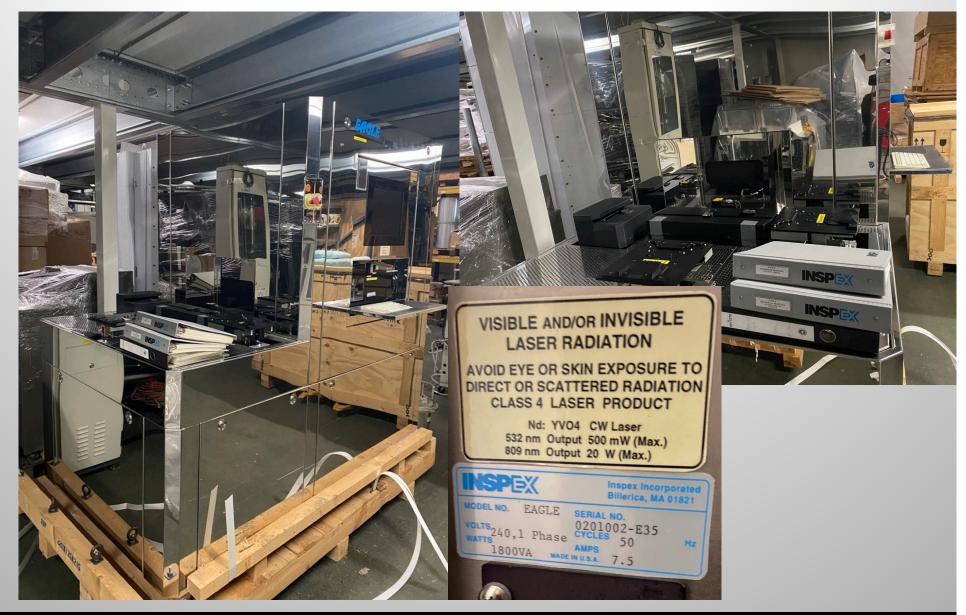


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## **KLA Tencor INSPEX EAGLE**

#### **Patterned Wafer Laser Inspection**





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